

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Sun et al.

Examiner: Thanh V. Pham

Serial No.: 10/621,292

Group Art Unit: 2823

Filed: July 17, 2003

For: **METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING A  
NICKEL SALICIDE PROCESS**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated November 28, 2006, please amend the above-referenced patent application as set forth herein.

---